
Low Frequency Measurement System

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Why do we need low frequency measurement

- Dispersion: integration of seismic, well-log and core data
- Attenuation: another attribute for DHI

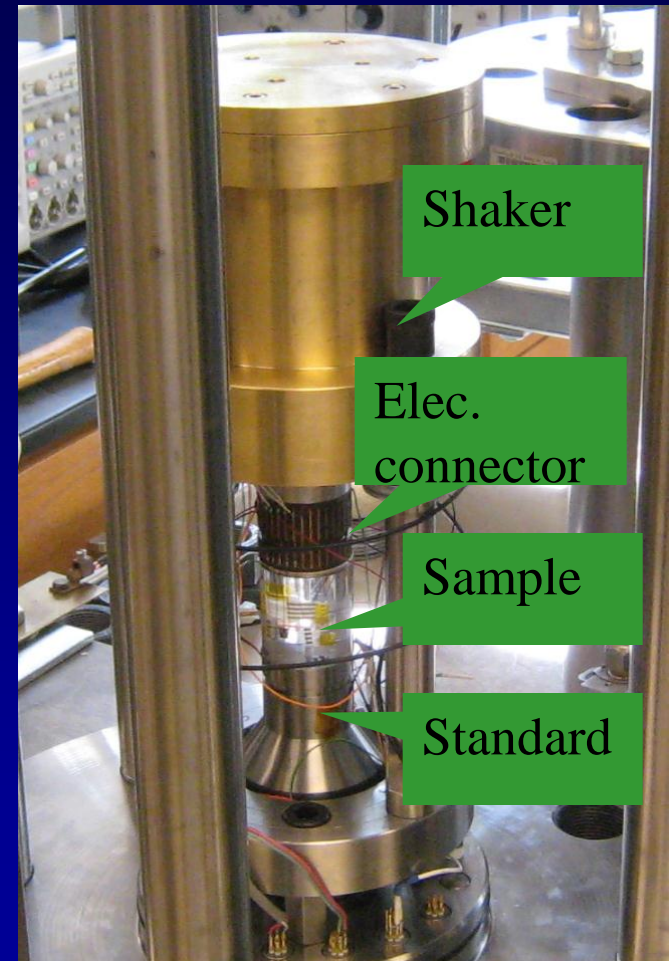
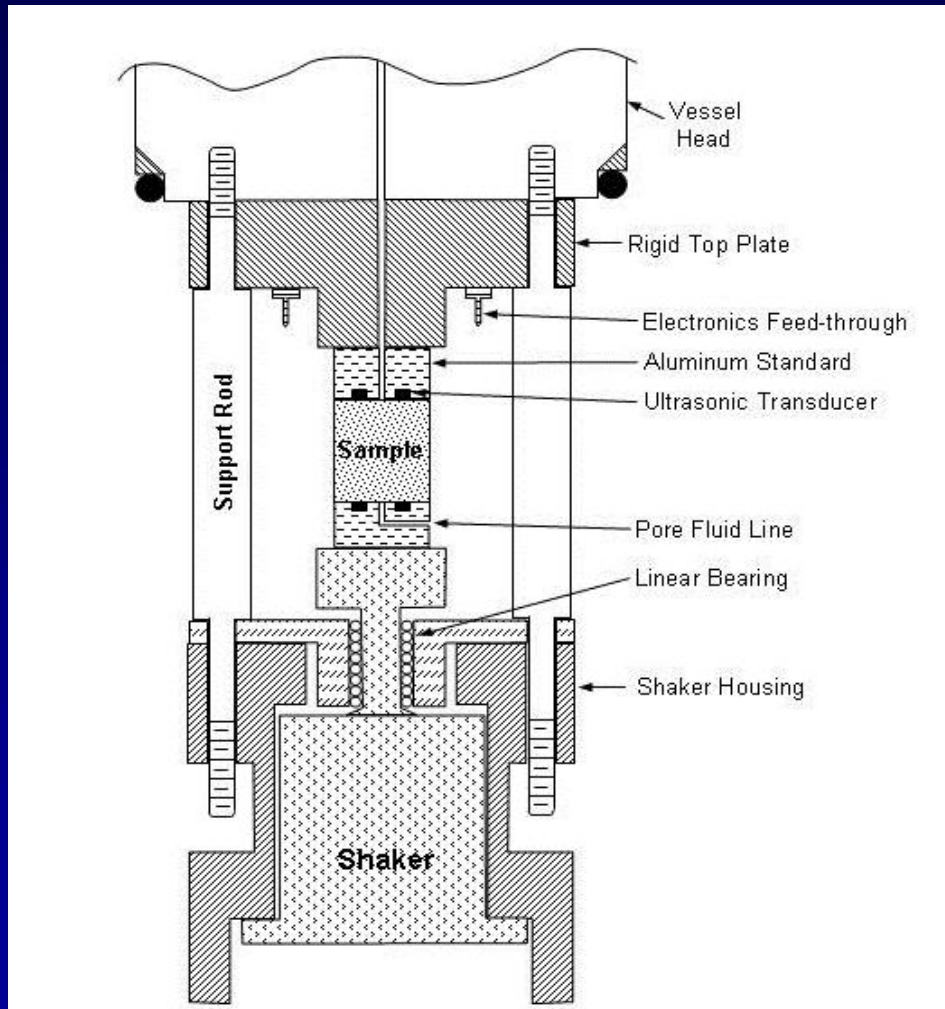


History for lab measurement

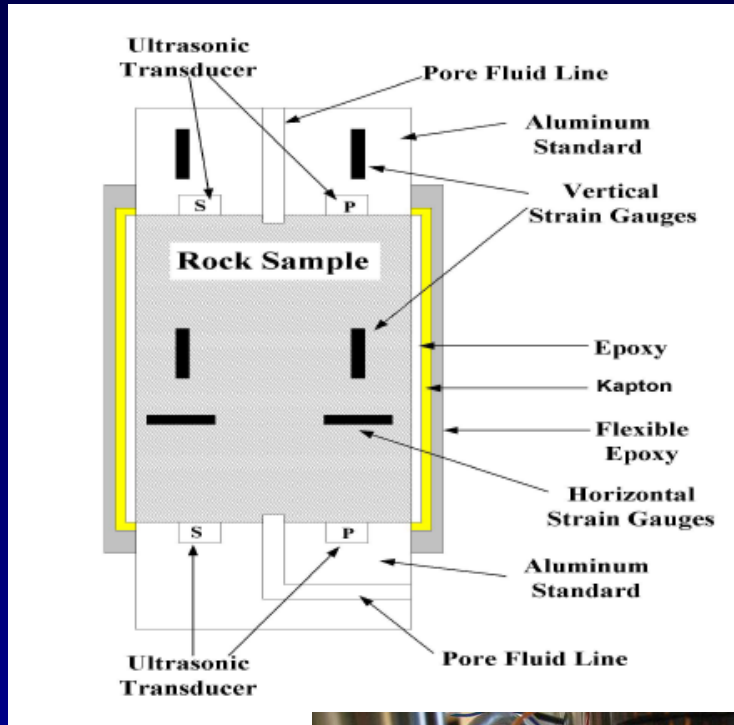
- Ultrasonic: ~MHz
- Resonant bar: >400Hz (logging)
- Force-deformation: Hz-1000Hz (seismic)



Low frequency system: principle



Low frequency system: principle



$$E = \frac{\sigma}{\epsilon_{\perp}}$$

$$\gamma = \frac{\epsilon_{\parallel}}{\epsilon_{\perp}}$$

$$\frac{1}{Q} = \tan(\theta)$$



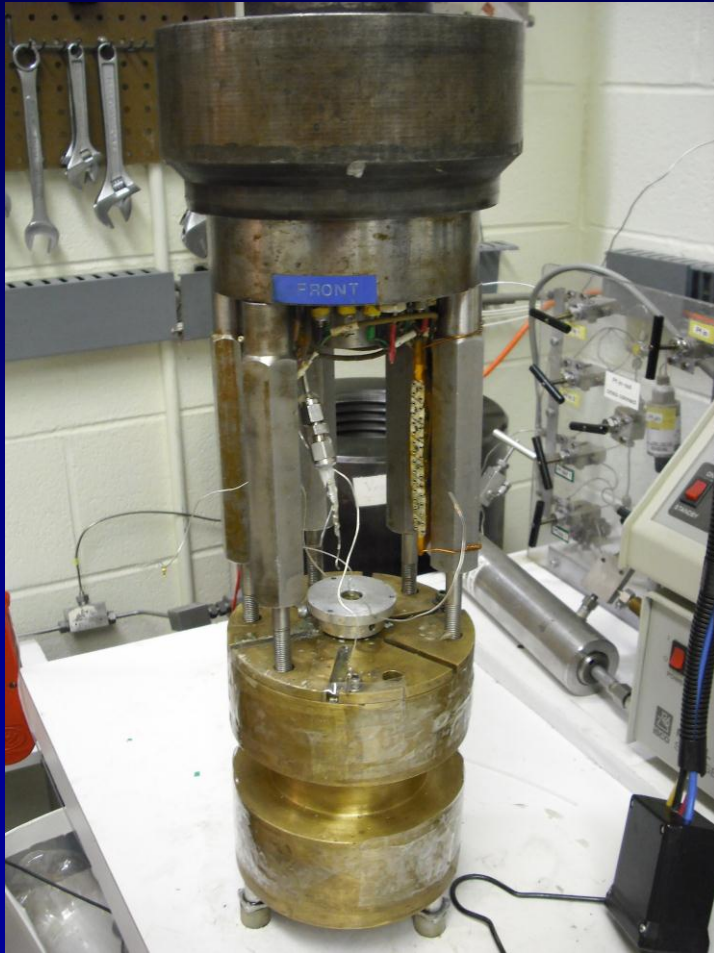
$$V_p = \sqrt{\frac{K + \frac{4}{3}\mu}{\rho}}$$
$$V_s = \sqrt{\frac{\mu}{\rho}}$$

Engineering challenges

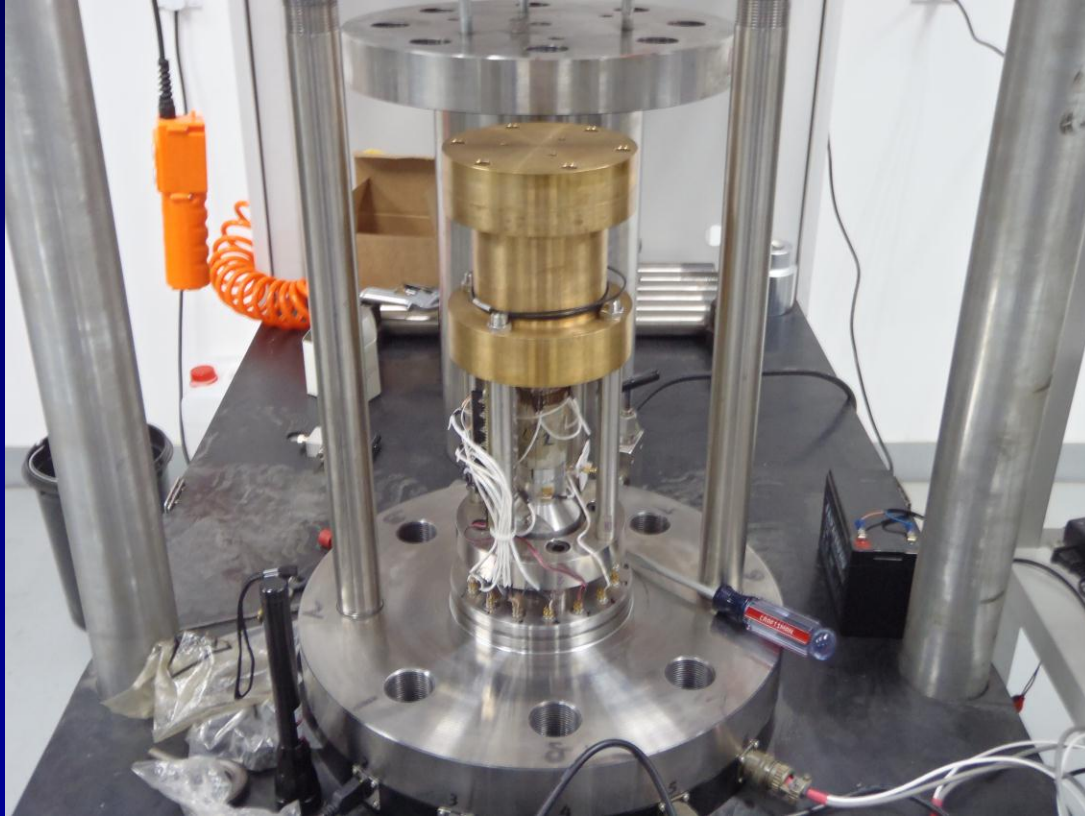
- Small strain $<10^{-6}$ and small output (μV)
- Results sensitive to amplitude and phase
- Special hardware and software need be developed
 - Small signal amplifier with differential input and shield driving
 - Lock-in amplifier to deal with low signal-noise ratio
 - 24 bit 16 channel NI acquisition system
- Multiple calibrations needed



Acknowledge: CSM & Shell

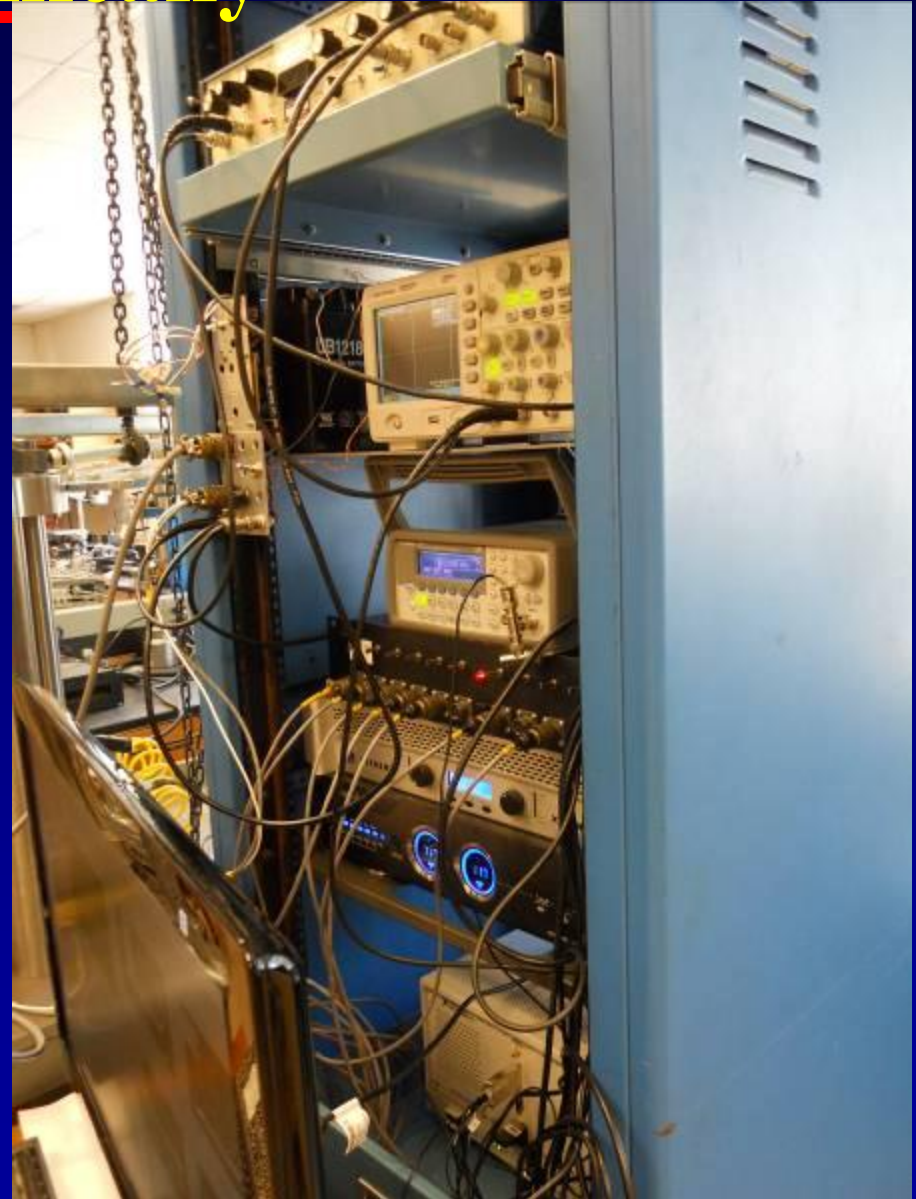
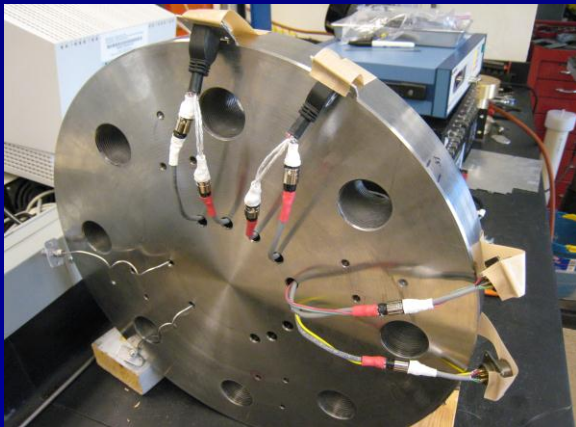


What's new: Mechanically

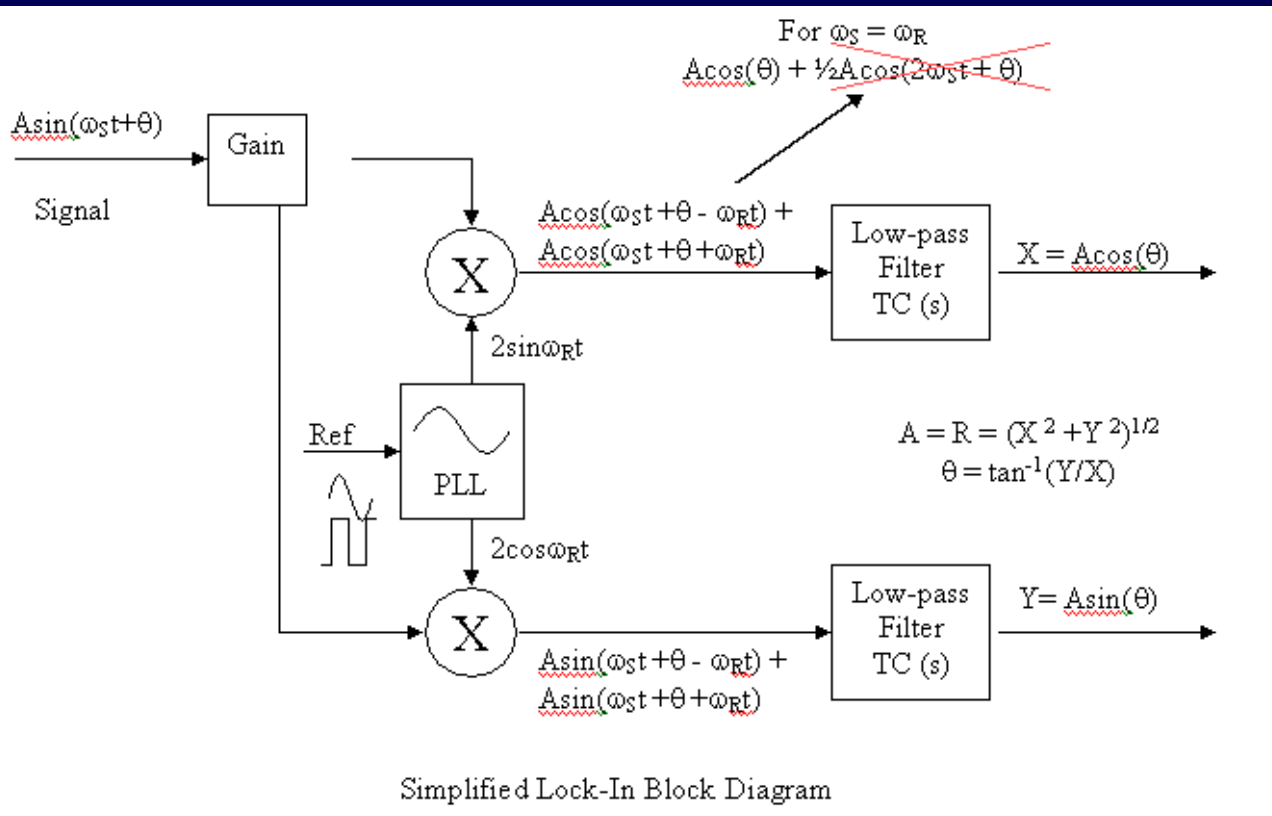


- Stationary sample assembly: more reliable
- In vessel shaker: better vibration mode

What's new: Electronically

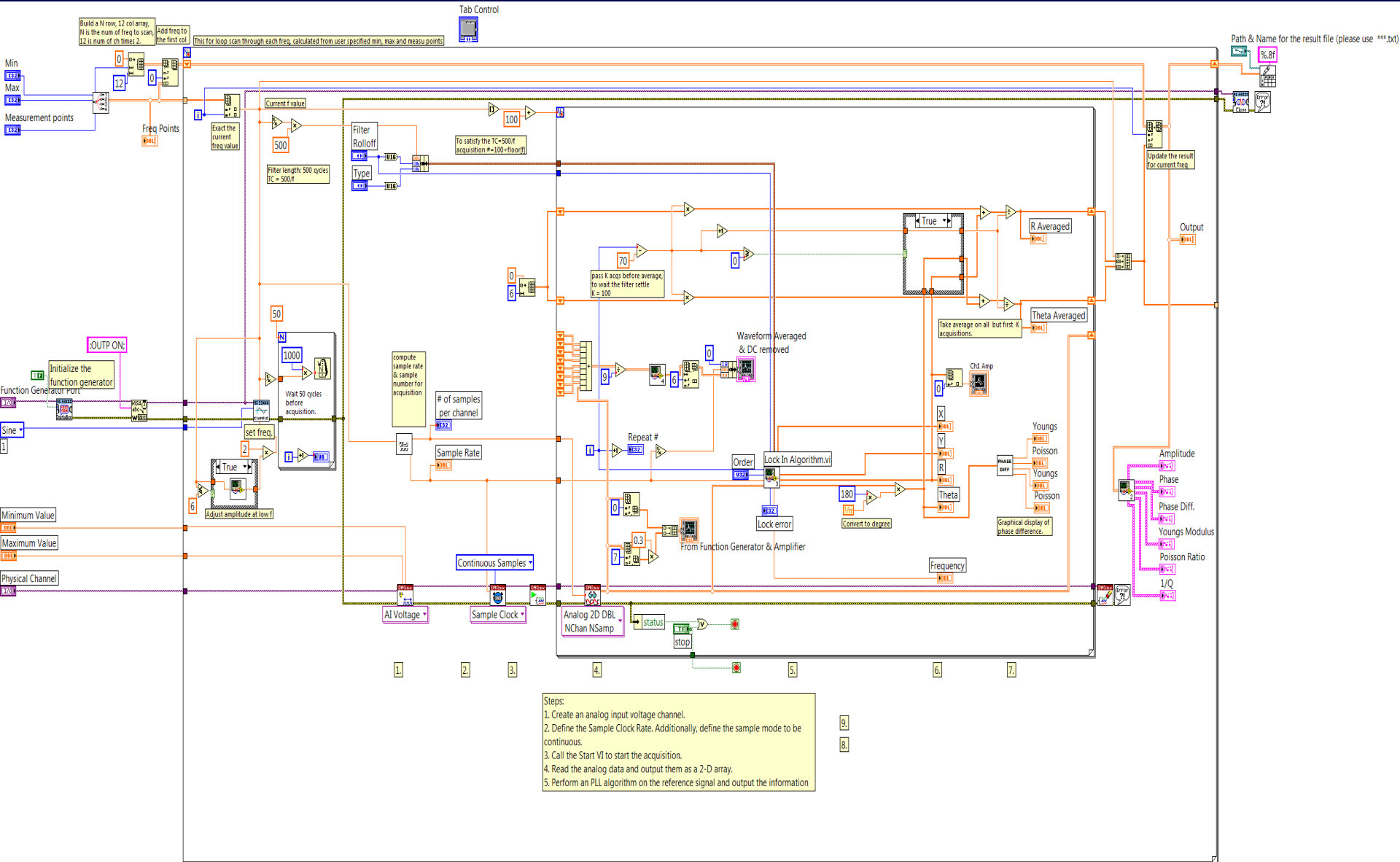


What's new: virtual lock-in amplifier



- 1st in the world
- Separate with acquisition hardware
- 16 channels, efficient & consistent
- Better integration with processing

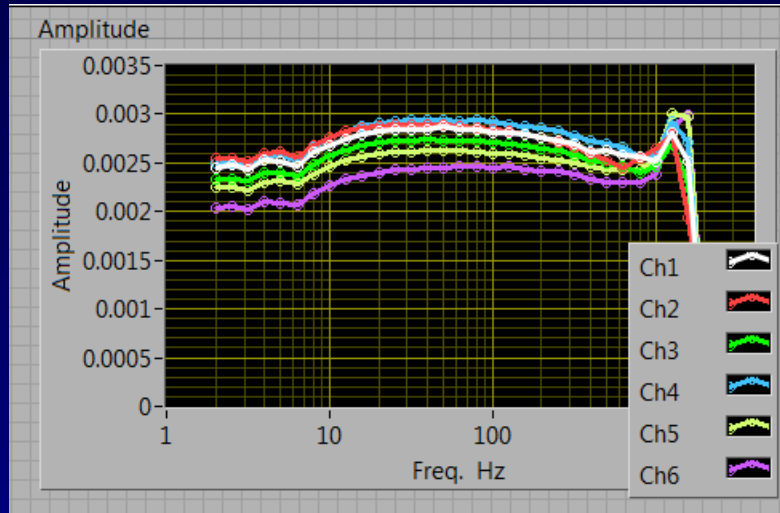
Software: acquisition, processing, automation



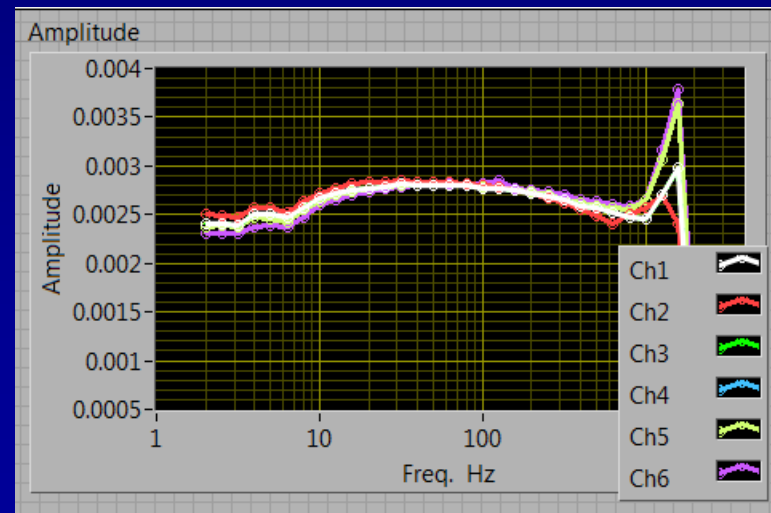
Software: acquisition, processing, automation



Calibration:

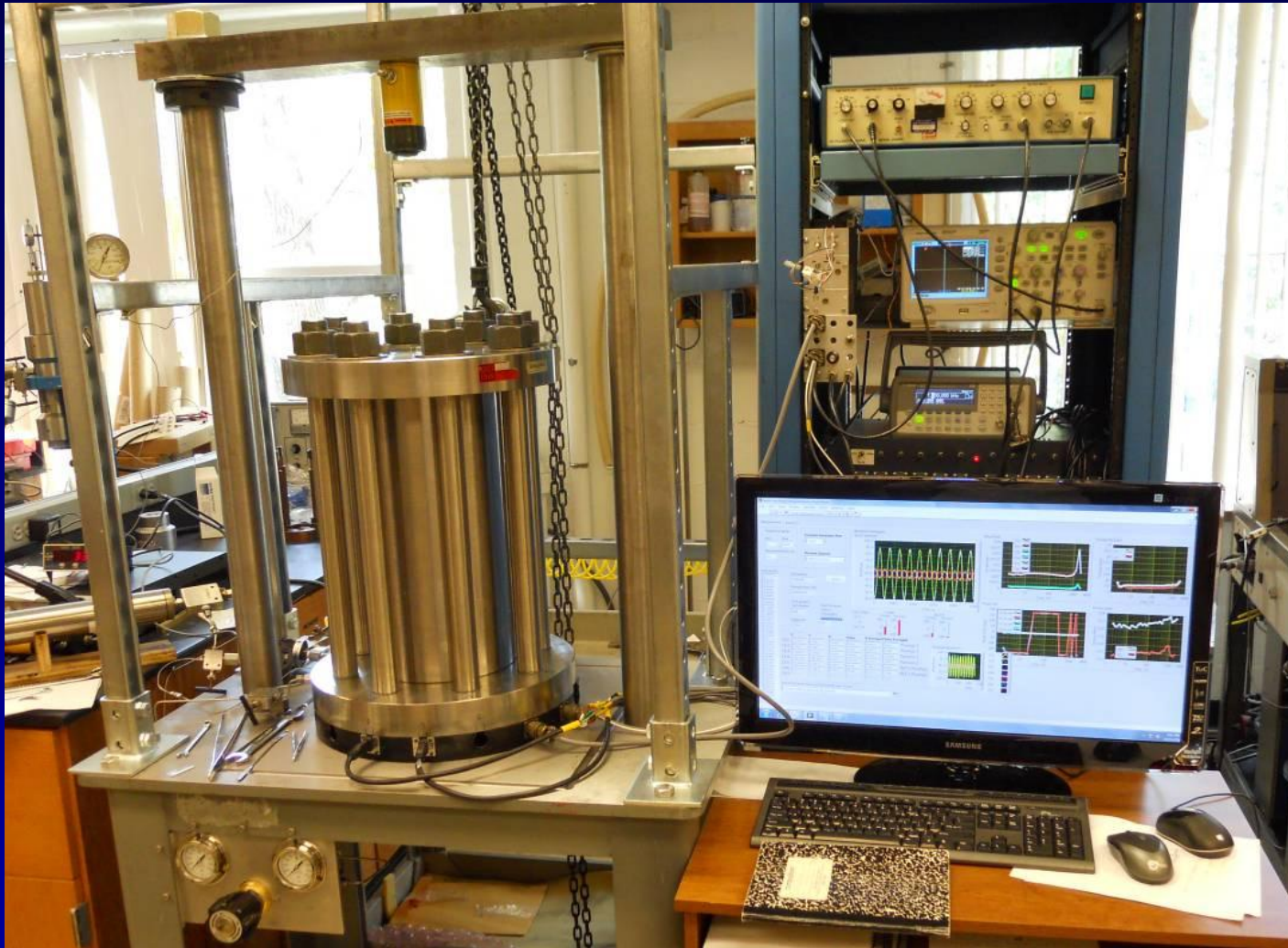


Before

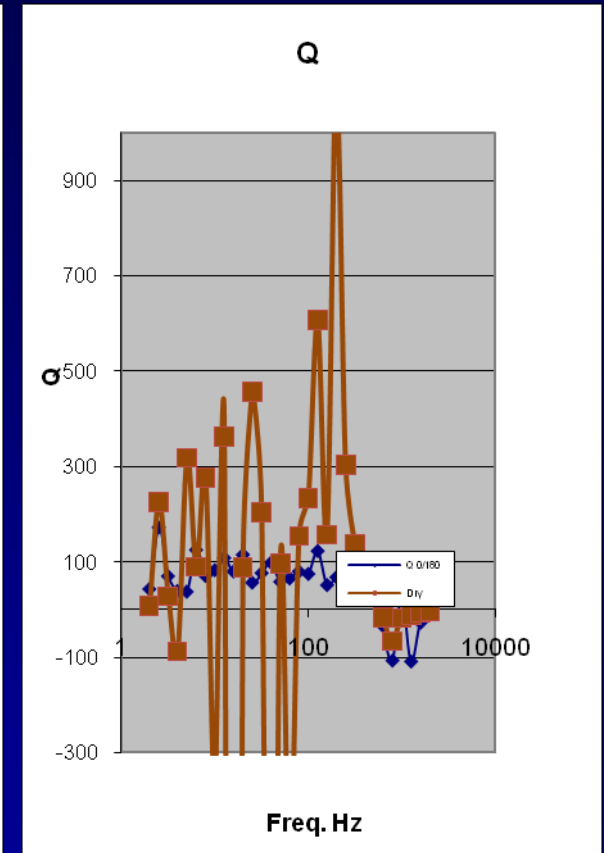
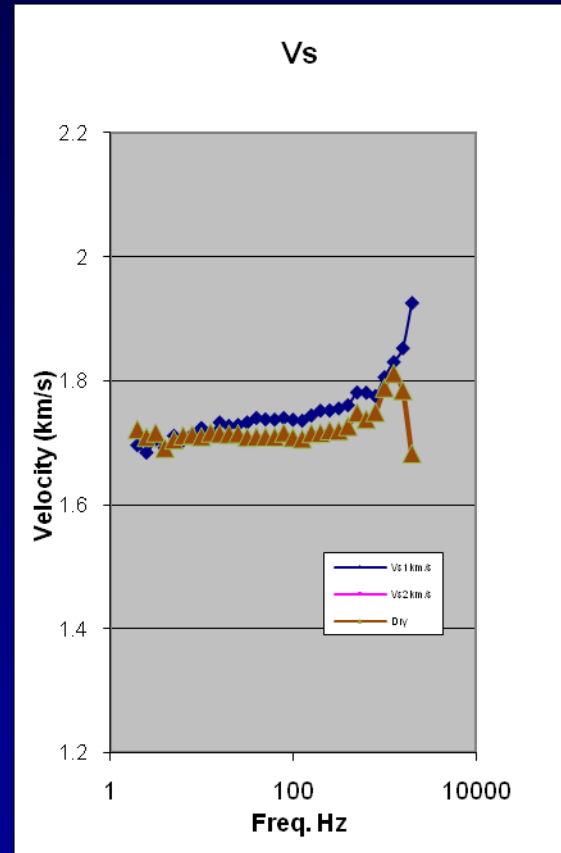
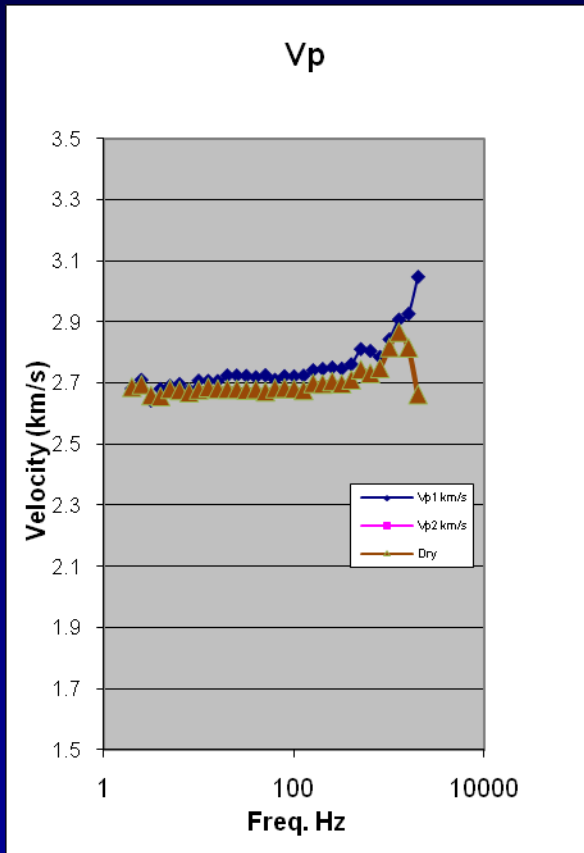


After

Whole system



Primary result: Dry vs. Butane saturation



THANK YOU !



Rock Physics Laboratory

